# CHE302 LECTURE II MEASUREMENT, TRANSMITTERS AND FILTERING

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# INTRODUCTION TO SENSOR

#### What is Sensor?

 Sensor converts the physical quantity to signal that can be recognized by other components such as display, transmitter and etc.

Physical Variable 
$$(T, P, F, L, x, ...)$$
 Sensor  $(V, mA, psig, ...)$ 

#### Sensor types

- Temperature: thermocouple, RTD, thermister
- Pressure: bellows, bourdon tube, diaphragm
- Flow rate: orifice, venturi, magnetic, ultrasonic, Coliolis effect
- Liquid level: float, differential pressure
- pH: pH electrode
- Viscosity: pressure drop across venturi or vane deflection
- Composition: density, conductivity, GC, IR, NIR, UV

#### MEASUREMENT DEVICE

#### Transducer: Sensor+Transmitter

- Transmitter generates an industrial standard signal from the sensoroutput.
- Standard instrumentation signal levels
  - Voltage: 1~5VDC, 0~5VDC, -10~+10VDC, etc.
  - Current: 4~20mA (long range transmission with driver)
  - Pneumatic: 3-15psig
- Signal conversion
  - I/P or P/I transducer: current-to-pressure or vice versa
  - I/V (I/E) or V/I: current-to-voltage or vice versa
  - P/E or E/P: pressure-to-voltage or vice versa

# Analog-to-Digital (A/D) converter

- Continuous signal converted to digital signal after sampling
- Specification: sample rate, resolution (8bit, 12bit, 16bit)

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## **TRANSMITTERS**

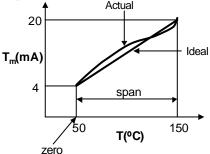
- Transmitter Gain (K<sub>m</sub>): adjustable
  - Amplification ratio: (output span)/(input span)
- Span and Zero: adjustable
  - Span: magnitude of range of transmitter signal
  - Zero: lower limit of transmitter signal

## Ex) Temp. Transmitter

$$K_{m} = \frac{(20 \, mA - 4mA)}{(150^{\circ}C - 50^{\circ}C)} = 0.16 \, [mA/^{\circ}C]$$

$$span = 100^{\circ}C$$

$$zero = 50^{\circ}C$$



Other functions: square-root extractor, ...

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### **TEMPERATURE SENSORS**

| Principle            | Туре                               | Usable range (°C)               | Remarks   |  |
|----------------------|------------------------------------|---------------------------------|---|--|
| Thermal<br>Expansion | Gas expansion<br>Liquid<br>Bimetal | -230~600<br>-200~350<br>-50~500 | N2<br>Oil   |  |
| Resistance           | Pt-100<br>Thermistor               | -200~500<br><300                | Accurate, linear, self heating Cheap, inaccurate, nonlinear |  |
| EMF                  | Thermocouple                       | -200~1600                       | Lowsensitivity  |  |
|                      | IC temp. sensor                    | -100~150                        | Highvoltage,accurate,linear                                 |  |
| Radiation            | Pyrometer                          | Very wide                       | Noncontacting, need accurate calibration                    |  |

**RTD** 

High

Wide

-400°F

+1200°F

Excellent

Good

High

Excellent

Medium

Medium

Good

Very low to low

Fair

Medium

**Medium to small** 

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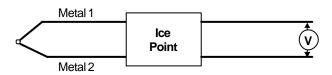
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| TemperatureSensorAdvantages/Disadvantages |  |   |  |  |  |
|---|--|---|--|--|--|
| Sensor                                    | Advantages   | Disadvantages   |  |  |  |
| Thermocouple                              | Self -powered Simple Rugged Inexpensive Wide variety Wide range  | •Non-linear •Lowvoltage •Reference required •Least stable •Leastsensitive   |  |  |  |
| RTD                                       | Most stable Mostaccurate More linear than thermocouple   | •Expensive •Currentsourcerequired •Small ♣ •Lowabsoluteresistance •Self heating   |  |  |  |
| Thermistor                                | Highoutput     Fast     Two-wireohmsmeasurement  | Non-linear     Limited range     Fragile     Currentsourcerequired     Self heating   |  |  |  |
| Infrared                                  | Nocontactrequired Veryfastresponsetime Good stability over time Highrepeatability Nooxidation/corrosiontoaffect sensor | High initial cost     Morecomplex/supportelectronics     Spotsizerestrictsapplication     Emissivity variations affect readings     Accuracy affected by dust, smoke and background radiation |  |  |  |

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## **THERMOCOUPLE**



- ThermocoupleTypes
  - Chromel- alumel (K- type): most popularly used
  - Iron- constantan (J- type): higher electromotive force (emf)
  - Chromel-constantan (E-Type): cryogenic temperature
  - -13% Rh. Pt Pt (R- type): high temperature (> 900 °C)
- Typical emf is about 0.041mV/PC for K type
  - Needs signal amplification
- Ice point can be a ice bath or an electronic device to compensate the ambient temperature.

**Temperature Sensor Attributes** 

**Thermocouple** 

Low

Very wide

-450°F

+4200°F

Good

Poor to fair

Medium

Poor to fair

Low

Medium to fast

Fair

Nο

Excellent

High

Smalltolarge

Criteria

Cost-OEM Quality

Interchangeability

Long-term Stability

Sensitivity(output)

Point(end)Sensitive

Accuracy

Response

Linearity

SelfHeating

LeadEffect

Size/Packaging

Repeatability

Temperature Range

**Thermistor** 

Low

Shottomedium

-100°F

+500°F

Poor to fair

Poor

Medium

Fair to good

Very high

Medium to fast

Poor

High

Good

Low

Smalltomedium

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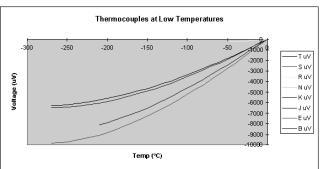
| Thermocoupletype       | Overall Range<br>(°C) | EMF<br>(mV/ °C) |
|------------------------|-----------------------|-----------------|
| B (Platinum/Rhodium)   | 100~1800              | 0.01            |
| E (Chromel/Constantan) | -270~790              | 0.068           |
| J (Iron/Constantan)    | -210~1050             | 0.054           |
| K (Chromel / Alumel)   | -270~1370             | 0.041           |
| N (Nicrosil / Nisil)   | -260~1300             | 0.038           |
| R (Platinum/Rhodium)   | -50~1760              | 0.01            |
| S (Platinum/Rhodium)   | -50~1760              | 0.01            |
| T (Copper/Constantan)  | -270~400              | 0.054           |

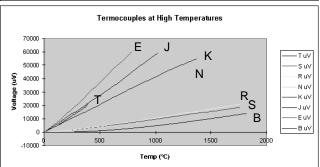
- B,R,S: high temp. low sensitivity, high cost
- S: very stable, use as the standard of calibration for the melting point of gold (1064.43°C).
- N: improved type K, getting more popular
- T: cryogenic use
- Ref: <a href="http://www.watlow.com/reference/refdata/TOP">http://www.watlow.com/reference/refdata/TOP</a> http://www.picotech.com/applications/thermocouple.html

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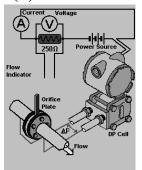
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# FLOW MEASUREMENT (1)

### **Differential Pressure Cell**

$$Q = \frac{C_d A_2}{\sqrt{1 - \left(A_2 / A_1\right)^2}} \sqrt{\frac{2 g_c \Delta P}{r}}$$

- $\Delta P$ : Delta P across the orifice
- A<sub>1</sub>: area of flow pipe
- A<sub>2</sub>: area of orifice
- C<sub>d</sub>: orifice coefficient
- Maximum pressure drop should be < 4% of the total line pressure
- Selection of orifice size and delta P range is very important for the reading precision





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# FLOW MEASUREMENT(2)

#### **Vortex Flow Meter**

- The vortices create low and high pressure zones behind the bluff body.
- The vortex meter uses a piezoelectric crystal sensor to detect the pressure exerted by the vortices on the sensing wing.
- The piezoelectric crystal converts this vortex shedding frequency into electrical signals.

# • Electromagnetic Flow Meter

- Electrically conducting fluid passing through a magnetic field created by the device.



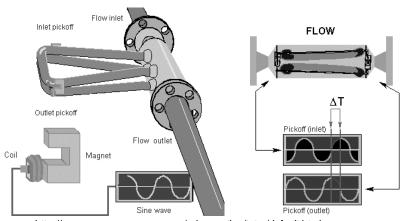
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## **CORIOLIS FLOWMETER (3)**

- Flow rate is measured by Coriolis effect (1835)
- Mass flowrate, vol. flowrate, temp. and density are simultaneously measured.





http://www.emersonprocess.com/micromotion/tutor/default.html

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Rangeability 4 to 1 10 to 1

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Coriolis

±0.5%

ofrate

very high

Clean.dirty

viscous liq.

andsome

slurry

none

none

10 to 1

low

low

Acoustic

offullspan

±1~5%

none

high

low

Dirty,

viscous liq.

and slurry

5 to 30

none

20 to 1

# FLOW MEASUREMENT (4)

- Ultrasonic Flow Meter
  - High accuracy
  - No contact with flow



- Positive Displacement Flow Meter
  - Turbine, gear, wheels
- Thermal Dispersion Flow Meter
  - Flow over heating coil will change temperature

## LEVEL MEASUREMENT

SELECTION OF FLOWMETERS

Vortex

±1.0%

ofrate

high

medium

medium

Clean.dirty

10 to 20

medium

10 to 1

liq.;

Electro-

Magnetic

±0.5%

ofrate

none

high

low

Clean, dirty

conductive

viscous

lig.and

slurry

none

40 to 1

5

Positive

displace

±0.2~0.5%

ment

ofrate

high

medium

medium

Clean

None

hiah

liq.

viscous

Orifice

±2~4%

offullspan

medium

low

high

Clean, dirty

liq.; some

slurry

10~30

high

Requirement

accuracy

Press.loss

**Initial Cost** 

Maintenance

Application

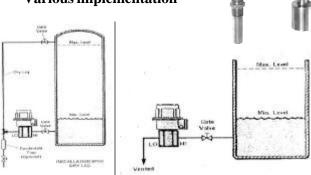
Upstreampipe

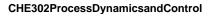
Viscosityeffect

cost

size

- Float level sensor
- Ultrasonic level sensor
- Use of DP cell
  - Measure fluid head as Delta P
  - Various implementation







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## OTHER MEASUREMENTS

# **Composition measurements**

- Expensive
- · Long time delay
- · High to maintenance cost
- **Gas Chromatography**
- IR, NIR, Raman, UV spectrophotometer
- pH sensor electrode: concentration of [H+]

# **Secondary Measurements**

- Density or temp. for binary composition
- Soft Sensors
  - Estimated by a model based on other measurements

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## **FILTERING**

#### **NoiseSource**

- Process nature (turbulence, vibration, oscillation...)
- Various noise source from environment
- Power line, electromagnetic force, etc.

## Removingnoise

Analog filter

Filtertimeconstant Filtered output

Previous filtered output

First-order filter analogy

$$t_{F} \xrightarrow{y_{F} - y_{F}^{0}} + y_{F} = y$$

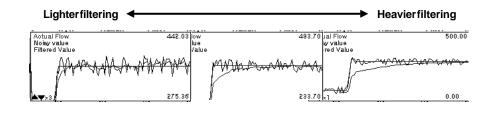
$$y_{F} = ay_{F}^{0} + (1-a)y \text{ where } a = \frac{t_{F}/\Delta t}{1 + t_{F}/\Delta t} (0 < a < 1)$$

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- The filter behaves as an interpolation between the measured output and previous filtered output.
- If a=1, the measured output is ignored. (constant)
- If a=0, the filtered output is same as the measured output (no filtering)
- If  $t_F = 0$ , a = 0 and no filtering is achieved.
- If  $t_F = \mathbf{Y}$ , a=1 and the measured output is ignored.

 $\mathbf{P}$  As  $t_{E}$  increases, heavier filter is applied.



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